

Extraction of COM Parameters and Quality Factor of One Port SAW Resonator using FEM Based Simulation

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Introduction

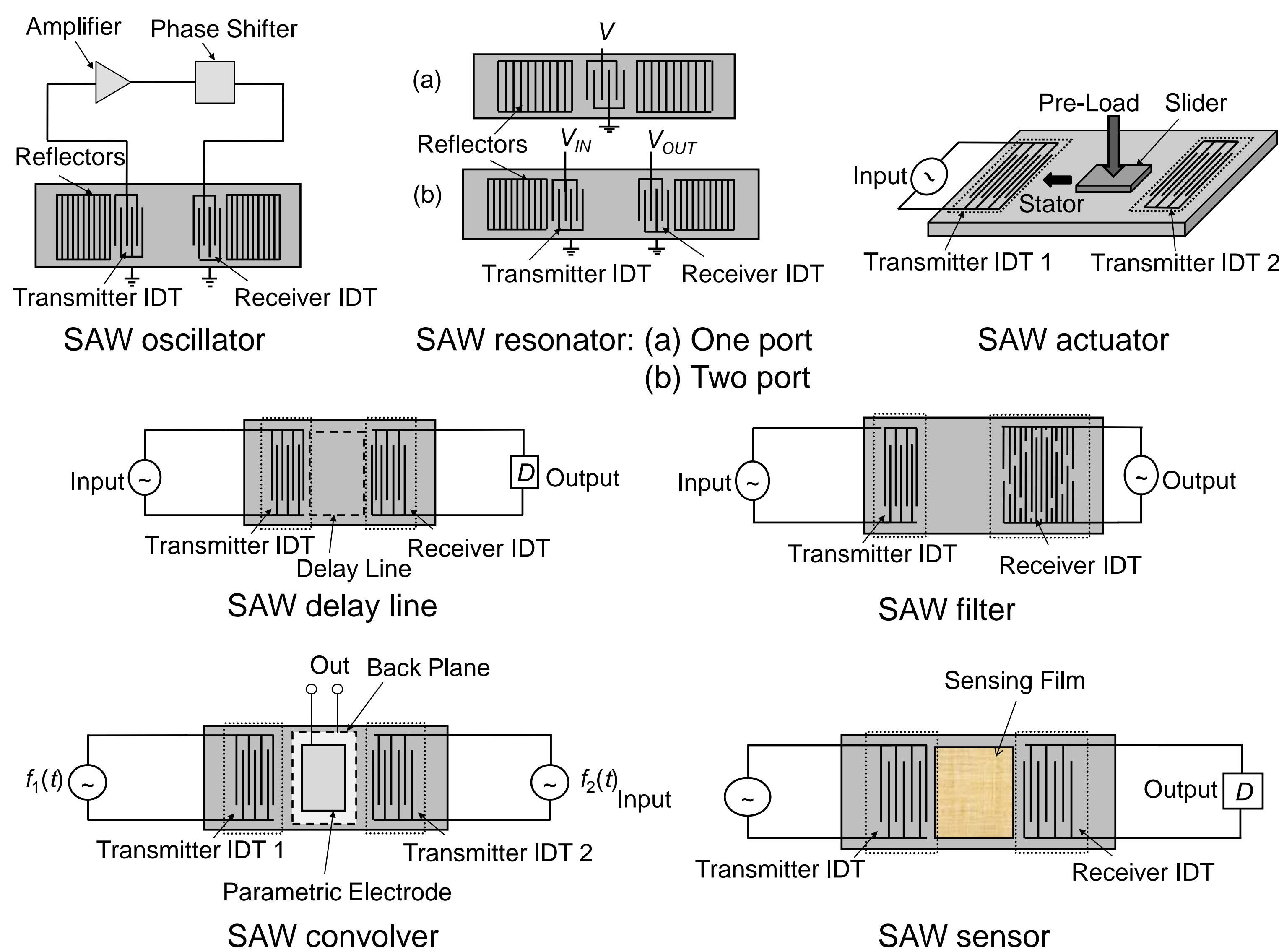
We present a method of **extraction of coupling of modes (COM) parameters and quality factor** for a one port surface acoustic wave (SAW) resonator from the results of finite element analysis in COMSOL Multiphysics.

The parameters are calculated for **various aspect ratios** of the interdigital transducer (IDT) electrodes. It is needed to reduce **resistive loss at high frequency** due to reduced size of IDT electrodes.

The calculation of COM parameters and quality factor for various aspect ratios of IDT electrodes is useful in **designing high frequency SAW devices**.

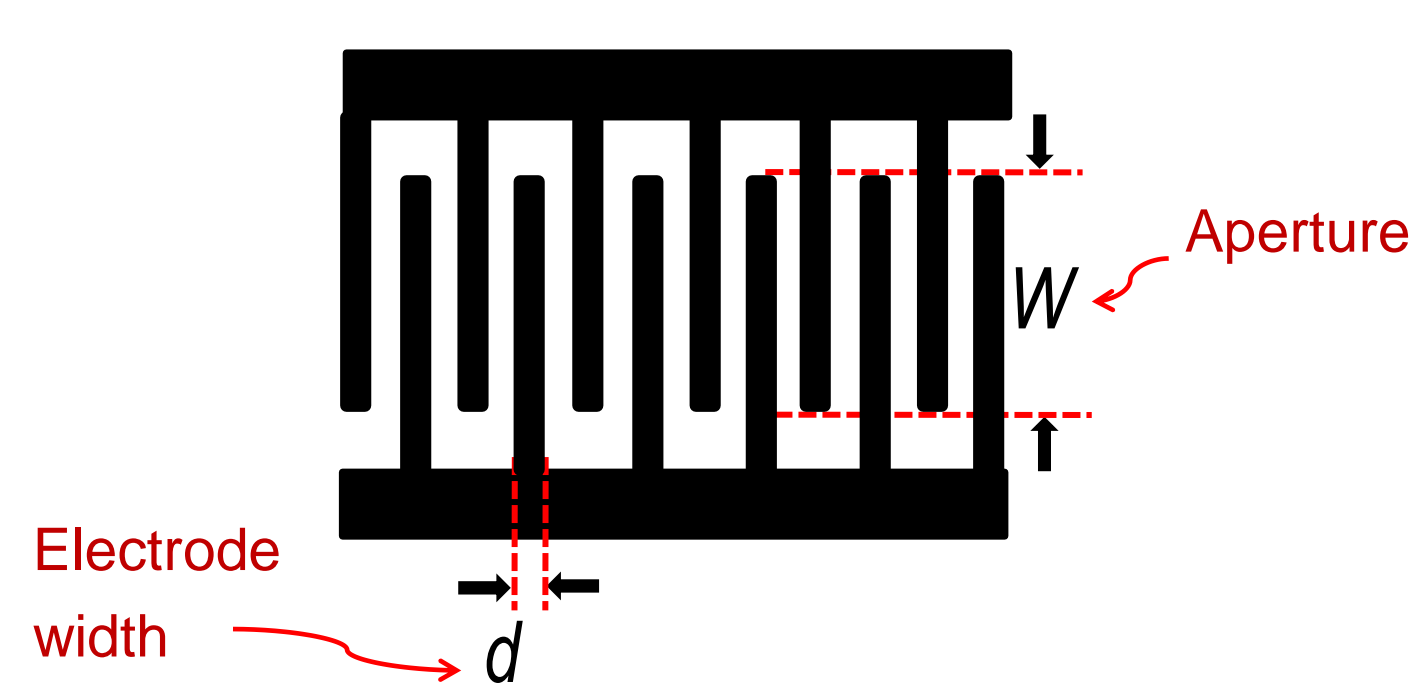
SAW Devices:

Popular devices which use SAW ¹⁻²



Interdigital Transducer (IDT):

- ✓ Developed by 'White' and 'Votmer' ⁴.
- ✓ Co-planar metal comb shape electrodes.
- ✓ Deposited on piezoelectric substrate.
- ✓ Converts electrical energy into mechanical energy and vice versa ².



$$\text{SAW wavelength } \lambda = 4d$$

$$\text{SAW frequency } f_0 = v/\lambda$$

Constitutive Equations¹

Stress tensor component

$$T_{ij} = \sum_k \sum_l c_{ijkl}^E S_{kl} + \sum_k e_{kij} E_k$$

Electric displacement component

$$D_i = \sum_j \epsilon_{ij}^s E_j + \sum_j \sum_k e_{ijk} S_{jk}$$

c_{ijkl}^E = stiffness tensor for constant electric field
 S_{kl} = strain tensor
 e_{kij} = elastic constant or piezoelectric tensor
 E_k = electric field
 D_i = electric displacement
 ϵ_{ij}^s = permittivity tensor for constant strain

Quality Factor and COM parameters Equations⁶

Quality factor

$$Q_r = \frac{f_r}{\Delta f}$$

Electromechanical coupling coefficient

$$K^2 = 2 \left(\frac{v - v_m}{v_f} \right)$$

Reflection coefficient

$$|\kappa_p| = \pi \left(\frac{f_{ar} - f_r}{f_0} \right)$$

SAW phase velocity

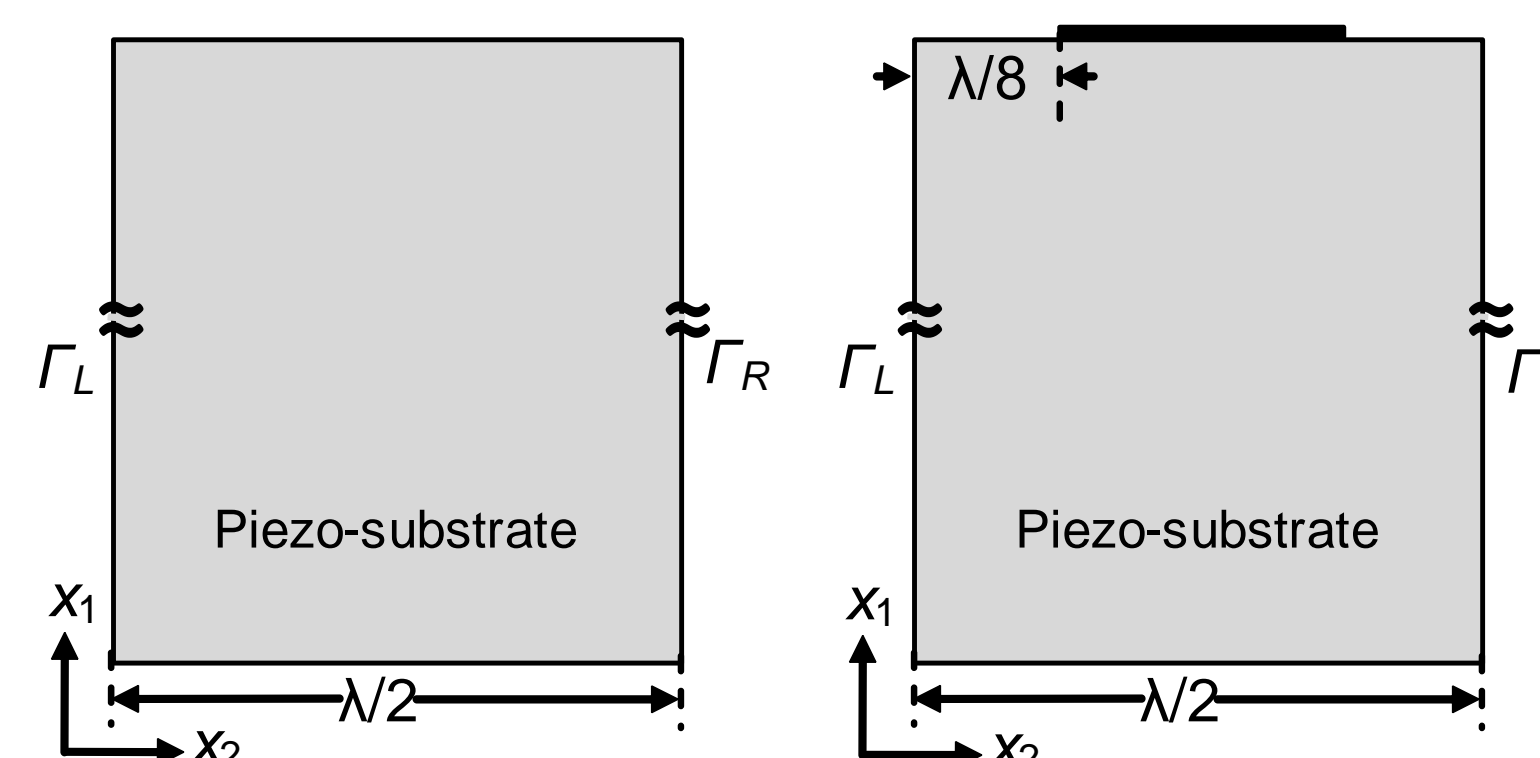
$$v = p(f_{ar} - f_r)$$

f_r = Resonance frequency of SAW resonator
 f_{ar} = Anti-resonance frequency of SAW resonator
 v_m = Metalized surface SAW phase velocity
 v_f = Free surface SAW phase velocity
 f_0 = Free surface resonance frequency
 p = Period of IDT electrodes

Modeling in COMSOL Multiphysics^{®3}

Geometry Settings:

- The 2D plane geometry of a simple piezo-substrate and a one port SAW resonator with periodic structure are modeled as shown below.
- The size of the piezo-substrate used is $1 \mu\text{m}$ (0.5λ) \times $20 \mu\text{m}$ (10λ).
- Various aspect ratios of the IDT electrodes are used.



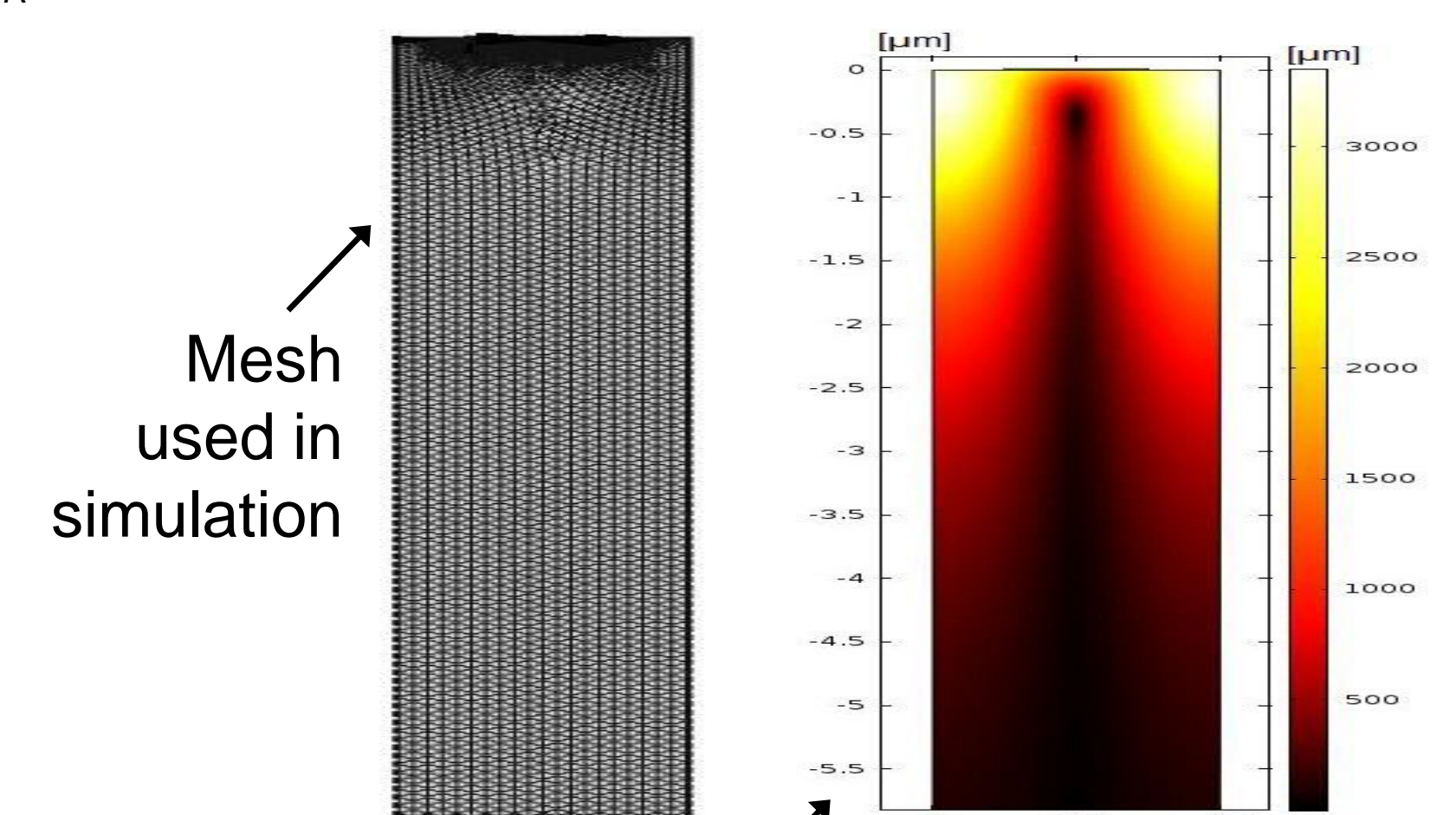
Sub-domain Settings:

- The substrate used for the simulation is YZ-cut LiNbO₃.

Boundary Settings:

- Boundary in the top of the substrate is given as $\mathbf{n} \cdot \mathbf{T} = 0$.
- The bottom surface is fixed as $u = 0$.
- Periodic boundary conditions⁵ are applied as follows

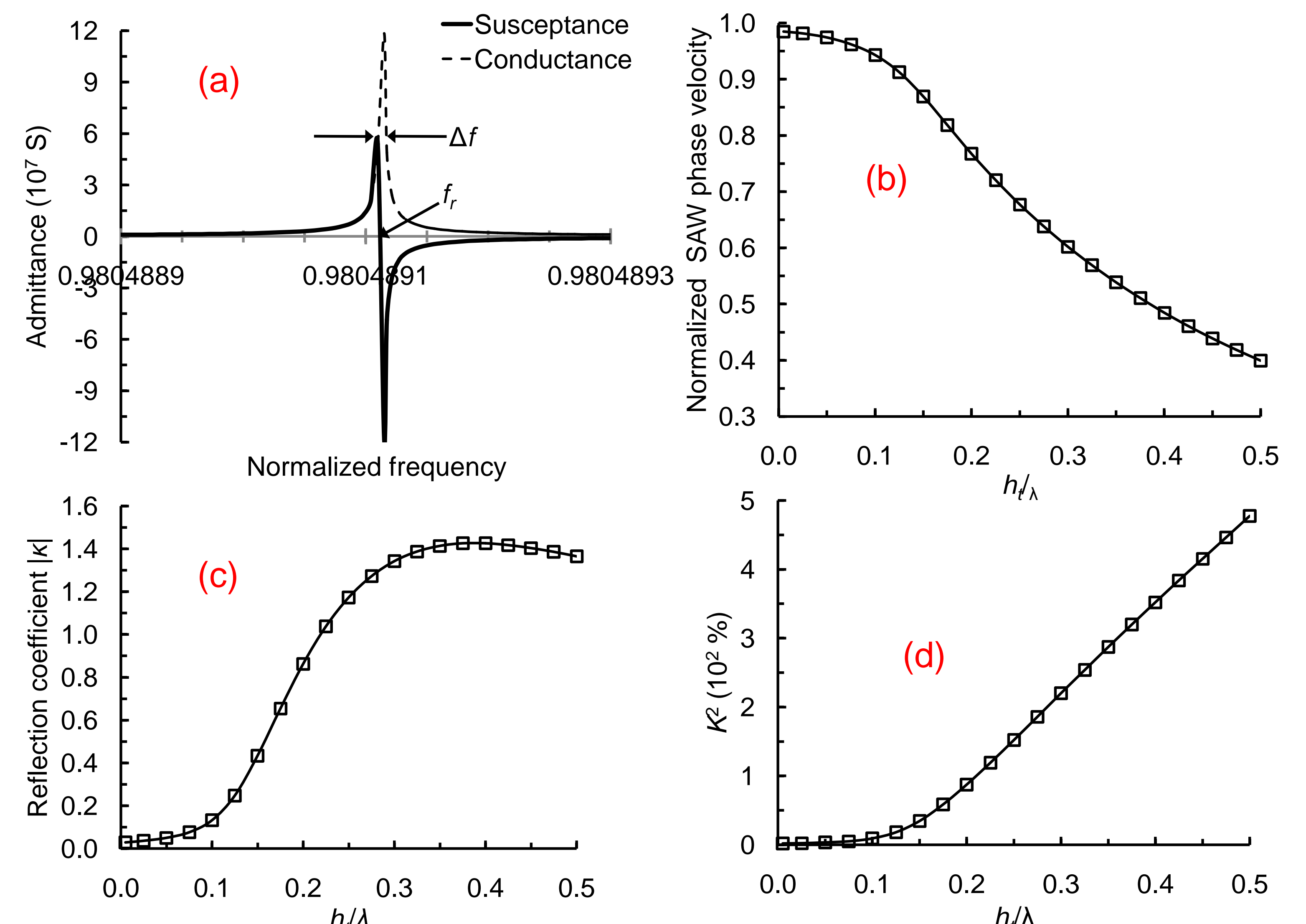
$$\Gamma_L(u, v, V) = \rho \Gamma_R(u, v, V), \quad \rho = (-1)^n, \quad n = 2a/\lambda$$



Mesh Settings:

- The extremely fine optimized mesh with 32 element per λ is used in all the simulation.

Results of Simulation in COMSOL Multiphysics[®]



- At high frequency SAW device, resistive loss occurs due to reduced size of IDT electrodes. It can be reduced by increasing the height of electrode.
- Quality factor of SAW resonator with IDT electrodes aspect ratio of 0.1 is about 1.5 order less than the aspect ratio of 0.005.
- High aspect ratio of IDT electrodes reduces the SAW phase velocity.
- Reflection and electromechanical coupling coefficient increase with increase in aspect ratio.

References

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